

An International Scholarly Open Access, Peer-reviewed, Refereed Journal

Ref No : JETIR / Vol 4 / Issue 3 / 092

**Confirmation Letter** 

To, Ambala Sudarshan Published in : Volume 4 | Issue 3 | 2017-03-14



Subject: Publication of paper at International Journal of Emerging Technologies and Innovative Research .

Dear Author,

With Greetings we are informing you that your paper has been successfully published in the International Journal of Emerging Technologies and Innovative Research (ISSN: 2349-5162). Following are the details regarding the published paper.

: An International Scholarly Open Access Journal, Peer-Reviewed, Refereed
Journal Impact Factor Calculate by Google Scholar and Semantic Scholar
AI-Powered Research Tool, Multidisciplinary, Monthly, Multilanguage Journal
Indexing in All Major Database & Metadata, Citation Generator, Impact Factor:
7.95, ISSN: 2349-5162
: UGC and ISSN Approved - UGC Approved Journal No: 63975   Link:
https://www.ugc.ac.in/journallist/subjectwisejurnallist.aspx?tid=MjM0OTUxNjI
=&&did=U2VhcmNoIGJ5IEITU04=
: JETIR 319628
: JETIR1703092
: Correlation of Nano Capacitance with Electrical Properties of Advanced
Materials
: 7.95 (Calculate by Google Scholar)
:
: Volume 4   Issue 3   2017-03-14
x 2017-03-14
: 487-493
: http://www.jetir.org/view?paper=JETIR1703092
: Ambala Sudarshan

Thank you very much for publishing your article in JETIR. We would appreciate if you continue your support and keep sharing your knowledge by writing for our journal JETIR.



An International Scholarly Open Access Journal, Peer-Reviewed, Refereed Journal

Email: editor@jetir.org

**JETIR.ORG**